

<b>FORM PTO-1449</b>  <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>  (Use several sheets if necessary)	<b>ATTY. DOCKET NO.</b> <b>30006571 US</b>	<b>APPLICATION NO.</b> <b>61/196,681</b>	<b>CONFIRMATION NO.</b> <b>PTO-1449</b>
	<b>APPLICANT</b> <b>Athena CHRISTODOULOU et al.</b>		
	<b>FILING DATE</b> <b>Herewith</b>	<b>GROUP</b>	

### **REFERENCE DESIGNATION**

## **U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
EP	1A 5,970,224	10/1999	Salgado et al.	395	115
1B					
1C					
1D					
1E					
1F					
1G					
1H					
1I					
1J					
1K					

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	TRANSLATION	
							YES	NO
1P	1L	0 595 594	05/1994	Yoshiyuki et al.	G06F	3/12		
	1M							
	1N							
	1O							
	1P							

**OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)**

fP	1Q	WPI Abstract of JP 10-143340 (5/1998).
fP	1R	Search Report dated April 19, 2001 from GB Application No. 0102415.7
	1S	

**EXAMINER**

**DATE CONSIDERED**

03/25/05

USSN 09/940,615

May 15, 2003

Page J

Form PTO-1449 (Modified)	ATTY DOCKET NO. B-5060 948588-3	U.S. SERIAL NO. 09/940,615
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANT(S) Athena Christodoulou, et al.	
	FILING DATE August 29, 2001	GROUP 2622

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
KP	5,287,194	2/1994	Lobiondo	358	296	
KP	5,970,224	10/1999	Salgado et al.	395	115	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO
KP	2000-250726	9/2000	JP			abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER	DATE CONSIDERED
MM	03/25/00

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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